# Characterization of p-BaSi<sub>2</sub>/n-Si solar cells using Boron-doped p-BaSi<sub>2</sub> on textured n-Si (001) grown by molecular beam epitaxy

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## [Introduction]

## Barium disilicide (BaSi<sub>2</sub>) has attractive features for solar cell application such as a suitable band <sup>[1]</sup>, a large minority-carrier lifetime ( $\tau \sim 10 \text{ } \mu\text{s}$ ) <sup>[2]</sup> and a large minority-carrier diffusion length ( $L \sim 10 \ \mu m$ ) <sup>[3]</sup>. Power conversion efficiency $(\eta)$ was expected to be larger than 25% only in a 2-µm-thick BaSi<sub>2</sub> pn junction diode<sup>[4]</sup>. In our previous work, it was demonstrated that *a*-axis of BaSi2 was oriented normal to the (111)-oriented texture on the Si(001) substrate and light trapping took place <sup>[5]</sup>. To ensure how thickness and hole concentration of boron(B)-doped p-BaSi<sub>2</sub> influence the performance of p-BaSi<sub>2</sub>/n-Si hetero-junction solar cell, in this study, we attempted to grow a series of B-doped p-BaSi2 with different thickness and hole concentration on textured Si (001).

# [Experiment]

First, a 5-nm-thick BaSi<sub>2</sub> layer was grown to control the crystal orientation of BaSi<sub>2</sub> over layers by reactive deposition epitaxy process. Second, approximately 20-, 50-, 75-, and 100-nm-thick B-doped BaSi<sub>2</sub> layers were grown by molecular beam epitaxy (MBE) with various sets of B K-cell temperature  $(T_{\rm B})$  and substrate temperature  $(T_{\rm S})$ .  $(T_{\rm B}, T_{\rm S})$  were set at (1230°C, 600 °C); (1230 °C, 650 °C), and (1300 °C, 650 °C), respectively, and the hole concentration (p)was found to be  $2.0 \times 10^{18}$ ,  $4.6 \times 10^{18}$ , and  $3.6 \times 10^{18}$  cm<sup>-3</sup>, respectively. Then, а 3-nm-thick a-Si layer was prepared over the BaSi<sub>2</sub> layers to prevent oxidation of BaSi<sub>2</sub>. After that, ITO electrode with a diameter of 1 mm and thickness of 80nm was sputtered on the front side. 150 nm Al was sputtered at the back. Afterwards, J-V characteristics and photoresponse were measured.

# [Results & Discussions]

Figure 1 shows *J-V* curves of a series of samples measured under AM1.5 illumination. p was  $3.6 \times 10^{18}$  cm<sup>-3</sup>. As the p-BaSi<sub>2</sub> film increases from 20 to 75 nm, the solar cell performance was improved. The conversion efficiency ( $\eta$ ) increases from 0.17% to 4.52% and the open-circuit voltage was increased from 0.04 to 0.30 V. For further increase in

p-BaSi<sub>2</sub> layer thickness up to 125 nm, however, the  $\eta$  goes down to 3.18% and the short-circuit current density decreases from 27.6 to 21.2 mA/cm<sup>2</sup>.

Figure 2 shows the EQE spectra of the samples of various  $p-BaSi_2$  thicknesses. With increasing the layer thickness, the EQE decreases especially in the short wavelength range, meaning that the contribution of photogenerated carriers in the  $p-BaSi_2$  becomes small.

### [Acknowledgments]

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### [Reference]

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**Fig. 1** *J-V* characteristics under AM1.5 illumination measured for samples with different p-BaSi<sub>2</sub> thicknesses.



**Fig. 2** *EQE* spectra for p-BaSi<sub>2</sub>/n-Si heterojunction solar cells with various p-BaSi<sub>2</sub> thicknesses.